

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No.09/847,165
Confirmation No.5640
Filing DateMay 1, 2001
Inventor.....David A. Atkinson, et al.
Assignee.....BechtelBWXT Idaho, LLC
Group Art Unit.....2881
ExaminerGurzo, Paul M.
Attorney's Docket No.LIT-PI-355
Customer No.21567
Title: Simultaneous Vaporization and Ionization Source for Particulate Matter Analysis by
Ion Mobility Spectrometry and Atmospheric Pressure Ionization Mass Spectrometry

STATEMENT OF THE SUBSTANCE OF SEPTEMBER 17, 2003 INTERVIEW

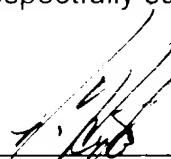
On September 17, 2003, an interview was conducted by telephone concerning the above referenced application. Participants of the interview were Examiner Paul M. Gurzo and Robert C. Hyta. The interview did not include any exhibits or demonstrations. In response to the Office communication dated July 11, 2003, I, Robert C. Hyta, do hereby set forth the substance of such interview.

The interview was initiated by Robert C. Hyta. It was concluded that ion chamber 11 of the Lewis reference does not include a reference device and a conductive conduit.

Respectfully submitted,

Dated: 10/5/03

By:


Robert C. Hyta
Reg. No. 46,791